

Attorney's Docket No. SON-2782

**DECLARATION AND POWER OF ATTORNEY FOR PATENT APPLICATION**  
**English Language Declaration**

As below named inventors, we hereby declare that:

Our residence, post office address and citizenship are as stated below next to our names.

We believe we are the original, first and joint inventors of the subject matter which is claimed and for which a patent is sought on the invention entitled

PHASE SHIFT MASK, FABRICATION METHOD THEREOF, AND FABRICATION METHOD OF SEMICONDUCTOR APPARATUS  
the specification of which

(check one)

is attached hereto.

X was filed on July 1, 2003 as

Application Serial No. PCT/JP2003/08377  
and was amended on \_\_\_\_\_

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information which is material to patentability as defined in Title 37, Code of Federal Regulations, §1.56.

I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent of inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

Prior Foreign Application(s)			Priority Claimed	
<u>P2002-193168</u>	<u>Japan</u>	<u>02/07/2002</u>	<u>X</u>	
(Number)	(Country)	(Day/Month/Year Filed)	Yes	No
<u>P2002-200777</u>	<u>Japan</u>	<u>10/07/2002</u>	<u>X</u>	
(Number)	(Country)	(Day/Month/Year Filed)	Yes	No
<u>PCT/JP2003/08377</u>	<u>WO</u>	<u>01/07/2003</u>	<u>X</u>	
(Number)	(Country)	(Day/Month/Year Filed)	Yes	No

We hereby claim the benefit under Title 35, United States Code, §120 of any United States application(s) listed below and insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code §112, I acknowledge the duty to disclose material to patentability as defined in Title 37, Code of Federal Regulations, §1.56 and 1.63(d) which became available between the filing date of the prior application and the national or PCT international filing date of this application:

(Application Serial No.)	(Filing Date)	(Status)
		(patented, pending, abandoned)

We hereby declare that all statements made herein of our own knowledge are true and that all statements made on information and belief are believed to be true, and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

**BEST AVAILABLE COPY**

Attorney's Docket Number: SON-2782

## English Language Declaration

POWER OF ATTORNEY: As a named inventor, I hereby appoint the following attorney(s) and/or agent(s) to prosecute this application and transact all business in the Patent and Trademark Office connected therewith.

Ronald P. Kananen, Reg. No. 24,104; Ralph T. Rader, Reg. No. 28,772;  
Michael D. Fishman, Reg. No. 31,951, Richard D. Grauer, Reg. No. 22,388;  
Joseph V. Coppola, Sr., Reg. No. 33,373; Michael B. Stewart, Reg. No.  
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Full name of first joint inventor Minoru SUGAWARA

Inventor's signature

Date 07/01/2005

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Full name of second joint inventor

Second Inventor's signature

Date

Residence

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Full name of third joint inventor

Third Inventor's signature

Date

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(Supply similar information and signature for subsequent joint inventors.)

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Docket No.: SON-2782  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Minoru Sugawara

Application No.: 10/519,449

Confirmation No.: 9573

Filed: December 30, 2004

Art Unit: N/A

For: PHASE SHIFT MASK, FABRICATION  
METHOD THEREOF, AND FABRICATION  
METHOD OF SEMICONDUCTOR  
APPARATUS

Examiner: Not Yet Assigned

**INDICATION OF TEN PRACTITIONERS UNDER 37 CFR § 1.32(c)**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

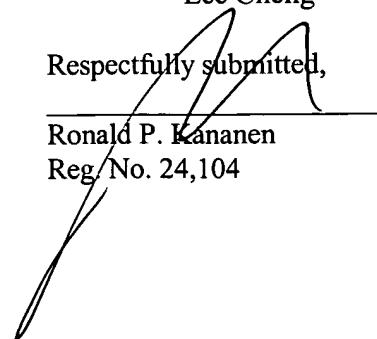
The undersigned, as an attorney or patent agent of record, requests the following ten patent practitioners named in the power of attorney to be recognized by the Patent and Trademark Office as being of record in application or patent to which the power of attorney is directed, under 37 C.F.R. § 1.32(c):

**Please associate Customer No. 23353 with this application.**

Name	Registration Number	Name	Registration Number
Ronald P. Kananen	24,104	Shawn B. Cage	51,522
Ralph T. Rader	28,772	Carl Schaukowich	29,211
Michael D. Fishman	31,951	Brian K. Dutton	47,255
Steven L. Nichols	40,326	Lee Cheng	40,949
Kristin L. Murphy	41,212		

August 25, 2005

Respectfully submitted,

  
\_\_\_\_\_  
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